

1FJ  
520.39728VX1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: M. HATANO, et al.

Application No.: 10/670,356

Filed: September 26, 2003

For: THIN FILM SEMICONDUCTOR DEVICE,  
POLYCRYSTALLINE SEMICONDUCTOR THIN FILM  
PRODUCTION PROCESS AND PRODUCTION APPARATUS

Art Unit: 2812

Examiner: Unknown

INFORMATION DISCLOSURE STATEMENT  
UNDER 37 CFR §§ 1.97 & 1.98

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

June 8, 2004

Sir:

In the matter of the above-identified application, applicants are submitting herewith copies of the documents listed in the attached form PTO/SB/08A for the Examiner's consideration. It is also noted that a Continuation application of the present application is being filed on even date herewith.

This Information Disclosure Statement is being submitted on information and belief, before the mailing date of a first office action on the merits.

It is respectfully requested that this Information Disclosure Statement be considered by the Examiner.

Please charge any shortage in the fees due in connection with the filing of this paper, including extension of time fees, to the deposit account of Antonelli, Terry,

Application No.: 10/760,356

Docket No.: 520.39728VX1

Stout & Kraus, LLP, Deposit Account No. 01-2135 (Docket No. 520.39728VX1), and  
please credit any excess fees to such deposit account.

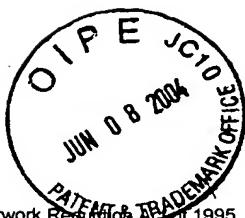
Respectfully submitted,

ANTONELLI, TERRY, STOUT & KRAUS, LLP

By   
\_\_\_\_\_  
Gregory E. Montone  
Reg. No. 28,141

GEM/dlt

1300 North Seventeenth Street, Suite 1800  
Arlington, Virginia 22209  
Telephone: (703) 312-6600  
Facsimile: (703) 312-6666



PTO/SB/08A (10-01)

Approved for use through 10/31/2002. OMB 0651-0031

Approved for use through 10/2018. GPO:2017-093-0001-0003.

Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it contains a valid OMB control number.

<p>Substitute for form 1449A/PTO</p> <p><b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b></p> <p><i>(use as many sheets as necessary)</i></p>				<b>Complete if Known</b>	
				<b>Application Number</b>	10/670,356
				<b>Filing Date</b>	September 26, 2003
				<b>First Named Inventor</b>	M. HATANO, et al.
				<b>Art Unit</b>	2812
				<b>Examiner Name</b>	Unknown
<b>Sheet</b>	1	<b>of</b>	1	<b>Attorney Docket Number</b>	520.39728VX1

OTHER PRIOR ART—NON PATENT LITERATURE DOCUMENTS				
Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.		T <sup>2</sup>

<b>Examiner Signature</b>		<b>Date Considered</b>	
-------------------------------	--	----------------------------	--

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

<sup>1</sup>Applicant's unique citation designation number (optional). <sup>2</sup>See Kinds Codes of USPTO Patent Documents at [www.uspto.gov](http://www.uspto.gov) or MPEP 901.04. <sup>3</sup>Enter Office that issued the document, by the two-letter code (WIPO Standard St.3). <sup>4</sup>For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>5</sup>Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. <sup>6</sup>Applicant is to place a check mark here if English language Translation is attached.

**Burden Hour Statement:** This form is estimated to take 2.0 hours to complete. Time will vary depending upon the needs of the individual case. Any comments on the amount of time you are required to complete this form should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, Washington, DC 20231. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Assistant Commissioner for Patents, Washington, DC 20231.